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## \*BIBDATASHEET\*

CONFIRMATION NO. 5389

Bib Data Sheet

<b>SERIAL NUMBER</b> 10/725,320	<b>FILING OR 371(c) DATE</b> 12/02/2003 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2829	<b>ATTORNEY DOCKET NO.</b> P69335US0	
<b>APPLICANTS</b> Kwan-Yong Lim, Ichon-shi, KOREA, REPUBLIC OF; Heung-Jae Cho, Ichon-shi, KOREA, REPUBLIC OF; Jung-Ho Lee, Ichon-shi, KOREA, REPUBLIC OF; Se-Aug Jang, Ichon-shi, KOREA, REPUBLIC OF; Yong-Soo Kim, Ichon-shi, KOREA, REPUBLIC OF; Byung-Seop Hong, Ichon-shi, KOREA, REPUBLIC OF; Jae-Geun Ho, Ichon-shi, KOREA, REPUBLIC OF; Hong-Seon Yang, Ichon-shi, KOREA, REPUBLIC OF; Hyun-Chul Sohn, Ichon-shi, KOREA, REPUBLIC OF;					
<b>** CONTINUING DATA *****</b>  <b>** FOREIGN APPLICATIONS *****</b> REPUBLIC OF KOREA 2003-43087 06/30/2003					
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 02/27/2004</b>					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged <u>Examiner's Signature</u> <u>Initials</u>		<b>STATE OR COUNTRY</b> KOREA, REPUBLIC OF	<b>SHEETS DRAWING</b> 8	<b>TOTAL CLAIMS</b> 15	<b>INDEPENDENT CLAIMS</b> 2
<b>ADDRESS</b> 43569					
<b>TITLE</b> Method for fabricating gate-electrode of semiconductor device with use of hard mask					
<b>FILING FEE RECEIVED</b> 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		